

# New Release

### **LTEC Corporation**

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# Si IGBT (1200V): ROHM Gen4 RGA80TRX2EHRC15 IGBT and FWD Structure Analysis Reports









Package / Internal layout

Si IGBT Die

Si FWD Die

#### **Overview**

In November 2024, ROHM released its 4th-generation 1200V IGBT for automotive applications, certified to the AEC-Q101 automotive standard. This fourth-generation 1200V IGBT is said to have a revised device structure, including the outer periphery, and is an IGBT characterized by a high breakdown voltage of 1200V, an industry-leading short circuit withstand time of 10 $\mu$ sec. (at Tj = 25° C), low switching loss, and low conduction loss.

LTEC released a structure analysis report on the new IGBT and FWD.

#### **Product features**

- Product type: RGA80TRX2EHRC15 VCES=1200V, Ic=69A
- Released data: November 2024
   https://fscdn.rohm.com/en/products/databook/datasheet/discrete/igbt/rga80trx2ehrc15-e.pdf
- TO-247-4L package
- Automotive Field Stop Trench IGBT
- Applications: Electric compressors for automobiles, Inverters for industrial equipment

#### Analysis Results (For details of the analysis, see pages 2 and 4)

#### (1) Si IGBT Structure Analysis Report: (65page)

• When compared with Infineon products (IGBT7), the current density of this product's IGBT is 4.1A/mm2 (calculated from collector current/transistor area), which is approximately 17% higher than Infineon's IGBT7. In addition, the IGBTs in this product use high-density trench technology that is almost equoal with the micropattern trench technology used in IGBT7.

#### (2) Si FWD Structure Analysis Report: (34page)

• This FWD is a PN junction diode.

#### Report price

Delivered one week after order placement Please contact us for report pricing.



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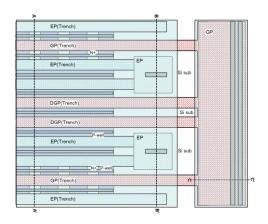
Report No : 24G-0821-1,2 Release day: 2025.03.03

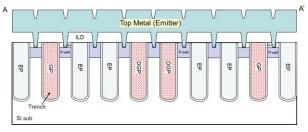
# **1** Si IGBT Structure Analysis Report Table of Contents

【Table of contents】				
1		Device summary		
		Table1-1: Device summary	• • •	3
	1-1.	Summary of analysis results	••• 4	
		Table1-2: Device structure: Si IGBT	• • •	5
		Table1-3: Device structure: Layer materials and thickness	• • •	6
2		Package analysis		
	2-1.	Appearance observation	• • •	8
	2-2.	Internal layout observation	• • •	10
3		Si IGBT die structure analysis		
	3-1.	Plane structure analysis by Optical Microscope	• • •	12
	3-2.	Plane structure analysis by SEM	• • •	28
	3-3.	Cell array cross-sectional structure analysis	• • •	41
	3-4.	Cross-sectional structure analysis of MOSFET die outer periphery	• • •	50
4		Comparison with the company's previous generation IGBT and Infineon's IGBT7		58
5		SR analysis		
	5-1.	SR analysis result overview		62
	5-2.	SR analysis points		63
	5-3.	SR analysis	• • •	64



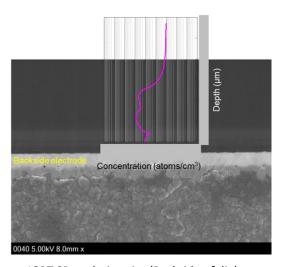
## **Excerpt from (1) Si IGBT Structure Analysis Report**



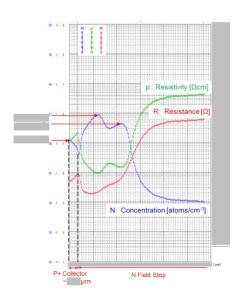


Schematic cross-sectional view of the cell array

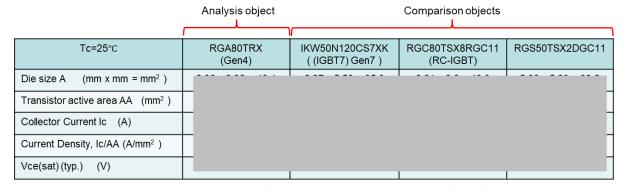
Schematic plane view of the cell array



IGBT SR analysis point (Backside of die)



IGBT SR analysis result (Backside of die)



Comparison with the company's previous generation IGBT and Infineon's IGBT7

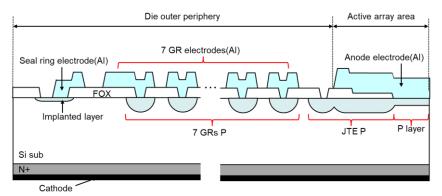


# (2) Si FWD Structure Analysis Report Table of Contents

【Table of contents】				
1		Device summary		_
		Table1-1: Device summary	• • •	3
	1-1.	Summary of analysis results	• • •	4
		Table1-2: Device structure: Si FWD		5
		Table1-3: Device structure: Layer materials and thickness		<u> </u>
2		Package analysis		
	2-1.	Appearance observation	• • • •	8
3		Si FWD die structure analysis		
	3-1.	Plane structure analysis by Optical Microscope	• • •	10
	3-2.	Plane structure analysis by SEM	• • •	16
	3-3.	Cross-sectional structure analysis	• • • •	17
4		SR analysis		
	4-1.	SR analysis result overview	• • •	31
	4-2.	SR analysis points	• • •	32
	4-3.	SR analysis	• • • •	33

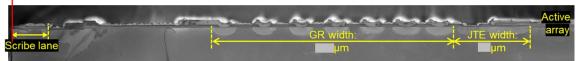


# **Excerpt from (2) Si FWD Structure Analysis Report**

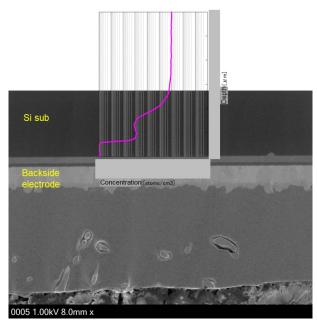


Schematic cross-sectional view of FWD

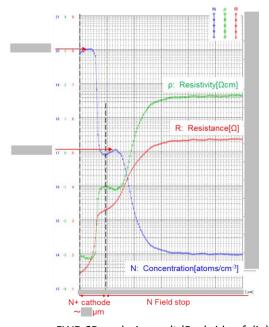
Die edge



Cross-sectional SEM image of die outer periphery



FWD SR analysis point (Backside of die)



FWD SR analysis result (Backside of die)

